



SCS Directory

Accreditation number: SCS 0074

International standard: ISO/IEC 17025:2017
Swiss standard: SN EN ISO/IEC 17025:2018

Mitutoyo (Schweiz) AG
Calibration laboratory
Steinackerstrasse 35
8902 Urdorf

Head: Daniel Wiederkehr
Responsible for MS: Andreas Kübler
Telephone: +41 44 736 11 50
E-Mail: daniel.wiederkehr@mitutoyo.ch
Internet: www.mitutoyo.ch
Initial accreditation: 18.12.1996
Current accreditation: 20.01.2022 to 19.01.2027
Scope of accreditation see: www.sas.admin.ch
(Accredited bodies)

Scope of accreditation as of 10.09.2025

Calibration laboratory for Length

Calibration and Measurement Capability (CMC)

Measured Quantity / Instrument or Gauge	Measurement Range	Measurement Conditions	Best Measurement Capability $\pm$ ¹⁾	Remarks
LENGTH Gauge blocks according to ISO 3650 - from steel - from ceramic	0,5 mm ... 100 mm + 131,4 mm	Measurement of the deviation of the central length by comparison measurement Measurement of the deviations f_o and f_u from the central length by 5 points comparison measurement	 0,06 μ m + 0,6 $\cdot$ 10 ⁻⁶ •L 0,06 μ m + 0,6 $\cdot$ 10 ⁻⁶ •L 0,05 μ m	



SCS Directory

Accreditation number: SCS 0074

Measured Quantity / Instrument or Gauge	Measurement Range	Measurement Conditions	Best Measurement Capability $\pm$ ¹⁾	Remarks
LENGTH				
Dial gauges	0 ... 100 mm	Resolution Digital 1 μm 10 μm Analog	1,5 μm 6 μm 3 μm	
Dial indicators	0 ... 3 mm		0,5 μm	
Dial test indicators	0 ... 1,6 mm		0,7 μm	
Micrometer Heads	0 ... 100 mm		3 μm + $10 \cdot 10^{-6} \cdot L$	
Inductive measure probe	0 ... 100 mm		0,5 μm + $10 \cdot 10^{-6} \cdot L$	
Micrometer	0 ... 105 mm		3 μm + $10 \cdot 10^{-6} \cdot L$	
Micrometer high-precision	0 ... 25 mm		0,5 μm + $10 \cdot 10^{-6} \cdot L$	
Caliper	0 ... 500 mm		20 μm + $20 \cdot 10^{-6} \cdot L$	
Height gauge	0 ... 600 mm	Resolution 0,1 μm	0,9 μm + $3 \cdot 10^{-6} \cdot L$	
Length measurement error E_0 according to EN ISO 10360-2 for co-ordinate measuring machines	Specified length measurement error E_0 , $\text{MPE} \geq 1,2 \mu\text{m} + 3 \cdot 10^{-6} \cdot L$ with $L \leq 1,5 \text{ m}$	Tactile measuring Specified operating conditions	E_0 : 0,5 μm + $0,2 \cdot 10^{-6} \cdot L$ manually CMMs 0,3 μm + $1 \cdot 10^{-6} \cdot L$ CNC CMMs	Further required parameters according to EN ISO 10360-2 are not determined. On-site calibration
Length measurement error E_0 according to EN ISO 10360-2 for co-ordinate measuring machines	500 mm ... 5000 mm	With laser interferometer	E_0 : 0,06 μm + $0,5 \cdot 10^{-6} \cdot L$	Further required parameters according to EN ISO 10360-2 are not determined. On-site calibration
Single-stylus form error P_{FTU} according to EN ISO 10360-5 for co-ordinate measuring machines		Tactile measuring Specified operating conditions	P_{FTU} : 0,11 μm	On-site calibration
Unidirectional length measurement error E_{UXY} and E_z for CMM equipped with imaging probing systems according to EN ISO 10360-7	Specified length measurement error $E_{UXY} \geq 1,2 \mu\text{m} + 3 \cdot 10^{-6} \cdot L$ with $L \leq 400 \text{ mm}$	Specified operating conditions	E_{UXY} and E_{UZ} : 0,4 μm + $0,5 \cdot 10^{-6} \cdot L$	Further required parameters according to EN ISO 10360-7 are not determined. On-site calibration

SCS Directory

Accreditation number: SCS 0074

Measured Quantity / Instrument or Gauge	Measurement Range	Measurement Conditions	Best Measurement Capability $\pm$ ¹⁾	Remarks
LENGTH				
Axially parallel unidirectional length measurement error E_{UXY} for projectors analogue to EN ISO 10360-7	cross table X-, Y-axis 0 ... 300 mm		E_{UX} and E_{UY} : $0,4 \mu\text{m} + 2,5 \cdot 10^{-6} \cdot L$	On-site calibration
Axially parallel unidirectional length measurement error E_{UXY} for measuring microscopes analogue to EN ISO 10360-7	cross table X-, Y-axis 0 ... 400 mm		E_{UX} and E_{UY} : $0,4 \mu\text{m} + 2,5 \cdot 10^{-6} \cdot L$	Also on-site calibration

* / * / * / * / *